

IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

**Inventor(s):** Yong Chen et al.

**Confirmation No.:**

**Application No.:**

**Examiner:**

**Filing Date:** August 15, 2003

**Group Art Unit:**

**Title:** IMPRINTING NANOSCALE PATTERNS FOR CATALYSIS AND FUEL CELL

**Commissioner for Patents**  
PO Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

**Sir:**

This Information Disclosure Statement is submitted:

under 37 CFR 1.97(b), or  
(Within three months of filing national application; or date of entry of national application; or before mailing date of first office action on the merits; whichever occurs last)

under 37 CFR 1.97(c) together with either a:  
 Statement under 37 CFR 1.97(e), or  
 a \$180.00 fee under 37 CFR 1.17(p), or  
(After the CFR 1.97 (b) time period, but before final action or notice of allowance, whichever occurs first)

under 37 CFR 1.97 (d) together with a:  
 Statement under 37 CFR 1.97(e)(1) or (2), and  
 a \$180.00 fee set forth in 37 CFR 1.17(p).  
(Filed after final action, a notice of allowance, on or before payment of the issue fee)

Please charge to Deposit Account **08-2025** the sum of **\$0.00**. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account **08-2025** pursuant to 37 CFR 1.25.

Applicant(s) submit herewith Form PTO 1449 - Information Disclosure Citation together with copies, of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

A concise explanation of the relevance of foreign language patents, foreign language publications and other foreign language information listed on PTO Form 1449, as presently understood by the individual(s) designated in 37 CFR 1.56 (c) most knowledgeable about the content is given on the attached sheet, or where a foreign language patent is cited in a search report or other action by a foreign patent office in a counterpart foreign application, an English language version of the search report or action which indicates the degree of relevance found by the foreign office is listed on form PTO 1449 and is enclosed herewith.

It is requested that the information disclosed herein be made of record in this application.

"Express Mail" label no. EV 323474166 US

Respectfully submitted,

Date of Deposit AUGUST 15, 2003

**Yong Chen et al.**

I hereby certify that this is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.

By Margaret Churchill

By Nancy Nolea

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Date: AUGUST 15, 2003

FORM PTO-1449		ATTY. DOCKET NO. <b>100110197-1</b>	APPLICATION NO.	CONFIRMATION NO.
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		APPLICANT <b>Yong Chen et al.</b>		
(Use several sheets if necessary)		FILING DATE	GROUP	

**REFERENCE DESIGNATION**      **U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION DATE	NAME	Pages, Columns, Lines Where Relevant Passages or Figures Appear
1A	5,338,430	August 16, 1994	Parsonage, et al.	
1B	5,772,905	June 30, 1998	Chou	
1C	6,136,412	Oct. 24, 2000	Spiewak, et al.	
1D	6,190,929 B1	Feb. 20, 2001	Wang et al.	
1E	6,294,450 B1	Sep. 256, 2001	Chen et al.	
1F	6,309,580 B1	Oct. 30, 2001	Chou	
1G	6,365,059 B1	Apr. 2, 2002	Pechenik	
1H	6,407,443 B2	Jun. 18, 2002	Chen et al.	
1I	6,432,740 B1	Aug. 13, 2002	Chen	
1J				
1K				

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	Pages/Columns/Lines Where Relevant Passages/Figures Appear	Check if Translation attached
1L					
1M					
1N					
1O					
1P					

**OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)**

1Q	Hu, Wenchong et al., "Growth of well-aligned carbon nanotube arrays on silicon substrates using porous alumina film as a nanotemplate," APPLIED PHYSICS LETTERS 79(19):3083-3085 (2001)
1R	
1S	

EXAMINER

DATE CONSIDERED